

Notice of References Cited		Application/Control No.	Applicant(s)/Patent Under Reexamination	
		09/772,858	KAMIJIMA, AKIFUMI	
Examiner		Art Unit		Page 1 of 1
Allan W. Olsen		1763		

U.S. PATENT DOCUMENTS

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
A	US-4,592,801	06-1986	Hara et al.	216/22
B	US-5,316,617	05-1994	Kawabe et al.	216/22
C	US-5,506,197	04-1996	Nakamura et al.	505/193
D	US-6,304,784	10-2001	Allee et al.	607/116
E	US-			
F	US-			
G	US-			
H	US-			
I	US-			
J	US-			
K	US-			
L	US-			
M	US-			

FOREIGN PATENT DOCUMENTS

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
N	JP 01175232 A	07-1989	Japan	TOUNO, HIROE	H01L 21/302
O	JP 04251853 A	09-1992	Japan	WATABE et al.	G03F 07/075
P					
Q					
R					
S					
T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Morimoto et al., "A GaAs Metal-Semiconductor Field-Effect Transistor With a Mushroom Gate Fabricated by Mixed Exposure of Focussed Ion Beams"□□J. Vac. Sci. Technology, B, Vol. 5 No. 1 January/February 1987, pages 211-214.□□
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.